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PATENT
Attorney Docket No. 14912.777

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stephen E. Savas

Application No.: 09/692,255

Filed: 10/19/2000

For: Systems and Methods for Photoresist Strip
And Residue Treatment in Integrated
Circuit Manufacturing

Group Art Unit: 1746

Examiner: Alexander Markoff

Mail Stop Fee Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Introductory Comments:

Applicants submit this Amendment in response to the Office Action mailed on December 4, 2003. Reconsideration of the above referenced application is respectfully requested in view of the following amendments and remarks.